

**STATEMENT UNDER 37 CFR 1.97(e) ACCOMPANYING
INFORMATION DISCLOSURE STATEMENT**

Docket No.
NEC N98039

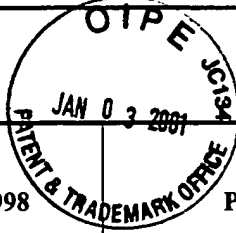
In Re Application Of: **MATASUDA**

Serial No.
09/222,524

Filing Date
DECEMBER 28, 1998

Examiner
PAREKH, N.

Group Art Unit
2811



Invention: **SEMICONDUCTOR DEVICE**

TO THE ASSISTANT COMMISSIONER FOR PATENTS:

This is a statement under the provisions of 37 CFR 1.97(e) in the above-identified application.

Check applicable statement herebelow:

Statement Under 37 CFR 1.97(e)(1)

- ☒ Each item of information contained in the accompanying information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement.

Statement Under 37 CFR 1.97(e)(2)

- ☐ No item of information contained in the accompanying information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the undersigned person, after making reasonable inquiry, no item of information contained in the accompanying information disclosure statement was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of the information disclosure statement.

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Signature

Norman P. Soloway, Reg. No. 24,315
Hayes, Soloway, Hennessey, Grossman & Hage, PC
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Manchester, New Hampshire 03101
603-668-1400

Dated: December 20, 2000

I certify that this document is being deposited on
December 21, 2000 with the U.S. Postal Service as first
class mail under 37 C.F.R. 1.8 and is addressed to the
Assistant Commissioner for Patents, Washington, D.C.
20231.


Signature of Person Mailing Correspondence

Johanne Hrycuna

Typed or Printed Name of Person Mailing Correspondence

CC:



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLN. OF: MATSUDA

SERIAL NO.: 09/222,524

FILED: DECEMBER 28, 1998

FOR: SEMICONDUCTOR DEVICE

GROUP: 2811

EXAMINER: PAREKH, N.

DOCKET: NEC N98039

Assistant Commissioner for Patents
Washington, D.C. 20231

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SUPPLEMENTAL PRIOR ART DISCLOSURE STATEMENT

Dear Sir:

In connection with the above-identified application, Applicant hereby attach U.S. Patent Office Form PTOL-1449, including a copy of the prior art reference listed therein. This reference was cited in the Korean Office Action dated September 21, 2000 of the underlying Korean patent application. Enclosed is the Korean Office Action as translated into the Japanese language, together with an English translation of the relevant portions thereof. The claims in the present application are believed to be patentably distinguished over this reference.

This prior art disclosure statement is being made pursuant to the duty of disclosure imposed by law and formulated in 37 CFR 1.56(A). No representation is made that the information thus disclosed in fact constitutes prior art or that it is the closest prior art, inasmuch as 37 CFR 1.56 (A) relies on a materiality concept which depends on subjectivity.

In compliance with the requirements of 37 C.F.R. §1.98(a)(3), as a concise statement of relevance, as it is presently understood by the individual designated in 35 U.S.C. §1.56(c) most knowledgeable about the content of the information, the undersigned attorney of record submits

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a translation of portions of an official action by a foreign examiner in which the reference was cited. The relevance to the pending U.S. patent application is that the reference was cited in a foreign patent application on the same subject matter. However, no independent analysis of the reference, the accuracy of the statement of the foreign examiner or the claims of the foreign application under the laws of the country or the United States relative to the subject matter claimed in the present application has been made; the present understanding of the contents thereof by the undersigned being based on the translation of the foreign examiner's comments submitted herewith.

The enclosed Prior Art Statement is being submitted within three months of the Korean Office Action, as certified in the attached Certification for Information Disclosure Statement. Therefore, we believe that there are no fees involved with this prior art disclosure statement. However, in the event there are any fees payable, please charge them to our Deposit Account No. 08-1391.

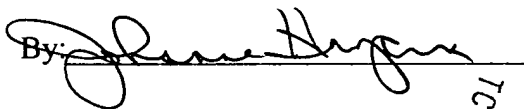
Respectfully submitted,



Norman P. Soloway
Attorney for Applicant
Reg. No. 24,315

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on December 21, 2000 at Manchester, New Hampshire.

By: 

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